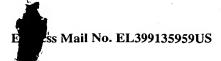
	Express than No. Ecoso 10000000
Applicant or Patentee: Imad Mahawili, PhD	Serial or Patent No.:
Filed or Issued:	ECCINIC A CENTICONIDUCTOR CURSTRATE
For: REACTOR WITH REMOTE PLASMA SYSTEM AND METHOD OF PROC	ESSING A SEMICONDUCTOR SUBSTRATE
VERIFIED STATEMENT (DECLARATION STATUS (37 C.F.R. § 1.9[f] and 1.27[c]) - S) CLAIMING SMALL ENTITY MALL BUSINESS CONCERN
I hereby declare that I am	
(X) the owner of the small business concern identified below:	
() an official of the small business concern empowered to act	on behalf of the concern identified below.
NAME OF CONCERN Micro C Technologies, Inc.	
ADDRESS OF CONCERN 4741 Talon Court, S.E., Kentwood, Michigan 49512	! I hereby declare that the above
identified small business concern qualifies as a small business concern as defin	ed in 13 C.F.R. § 121.3-18, and reproduced in 37 C.F.R. § 1.9(d),
for purposes of paying reduced fees under sections 41(a) and (b) of Title 35, Un	ited States Code, in that the number of employees of the concern,
including those of its affiliates, does not exceed 500 persons. For purposes of the	is statement, (1) the number of employees of the business concern
is the average over the previous fiscal year of the concern of the persons emplo	yed on a full-time, part-time or temporary basis during each of the
pay periods of the fiscal year, and (2) concerns are affiliates of each other when	either, directly or indirectly, one concern controls or has the power
to control the other, or a third party or parties controls or has the power to control	ol both.
I hereby declare that rights under contract or law have been conveyed to and re	main with the small business concern identified above with regard
to the invention, entitled REACTOR WITH REMOTE PLASMA SYSTEM AND M	METHOD OF PROCESSING A SEMICONDUCTOR SUBSTRATE
by inventor Imad Mahawili, PhDdescribed in	•
(X) the specification filed herewith. () application serial no, filed () patent no, issued	
If the rights held by the above identified small business concern are not exclusive	sive, each individual, concern or organization having rights to the
invention is listed below* and not rights to the invention are held by any person	, other than the inventor, who could not qualify as an independent
inventor under 37 C.F.R. § 1.9(c) or by any concern which would not qualify as	a small business concern under 37 C.F.R. § 1.9(d) or a nonprofit
organization under 37 C.F.R. § 1.9(e). *NOTE: Separate verified statements are	required from each named person, concern or organization having
rights to the invention averring to their status as small entities (37 C.F.R. § 1.27	').
NAME	
ADDRESS () INDIVIDUAL () SMALL BUSINESS CONCERN () NON-PROFIT	ORGANIZATION
I acknowledge the duty to file, in this application or patent, notification of any ch	ange in status resulting in loss of entitlement to small entity status
prior to paying, or at the time of paying, the earliest of the issue fee or any main	tenance fee due after the date on which status as a small entity is
no longer appropriate. (37 C.F.R. § 1.28[b]).	
I hereby declare that all statements made herein of my own knowledge are true a	and that all statements made on information and belief are believed
to be true; and further that these statements were made with the knowledge that	willful false statements and the like so made are punishable by fine
or imprisonment, or both, under Section 1001 of Title 18 of the United States Coo	le, and that such willful false statements may jeopardize the validity
of the application, any patent issuing thereon, or any patent to which this verifie	d statement is directed.





DECLARATION AND POWER OF ATTORNEY

As a below named inventor, I hereby declare:

My residence, post office address and citizenship are as stated below next to my name.

I believe I am the original, first and sole inventor, if only one name is listed below, or an original, first and joint inventor, if plural names are listed below, of the subject matter which is claimed and for which a patent is sought on the invention entitled REACTOR WITH REMOTE PLASMA SYSTEM AND METHOD OF PROCESSING A SEMICONDUCTOR SUBSTRATE, the specification of which is attached hereto.

I have reviewed and understand the contents of the above-identified specification, including the claims, as amended by any amendment referred to above.

I acknowledge the duty to disclose to the United States Patent and Trademark Office (the Office), all information which is known by me to be material to patentability as defined in Title 37, Code of Federal Regulations (C.F.R.), Section 1.56.

CLAIM OF PRIORITY

application(s) for patent or inventor's certificate listed below and have also identified below any foreign application for paten
or inventor's certificate having a filing date before that of the application on which priority is claimed.
Application Ser. No. None, filed in (country) on
I hereby claim the benefit under 35 U.S.C. § 120, of any United States application(s) listed below and, insofar as the above-identified specification, including claims, discloses and claims subject matter in addition to that disclosed in the prior copending application(s), listed below, I acknowledge the duty to disclose to the Office, all information which is known by me to be material to patentability as defined in 37 C.F.R. § 1.56, which became available between the filing date of the prior application and the national or PCT international filing date of this application.
U.S. Serial No. None, filed on
I hereby claim the benefit under Title 35, United States Code, § 119(e) of any United States provisiona application(s) listed below: U.S. Serial No, filed on

POWER OF ATTORNEY

I hereby appoint the patent law firm of Van Dyke, Gardner, Linn & Burkhart, LLP, 2851 Charlevoix Drive, S.E., Suite 207, Grand Rapids, Michigan 49546, telephone number 616/975-5500, facsimile number 616/975-5505, and the individual patent attorneys and patent agents at such patent law firm, namely, Daniel Van Dyke, Reg. No. 25 046; Donald S. Gardner, Reg. No. 25 975; Terence J. Linn, Reg. No. 30 283; Frederick S. Burkhart, Reg. No. 29 288; Catherine S. Collins, Reg. No. 37 599; Matthew L. Goska, Reg. No. 42 594; Anthony A. Bisulca, Reg. No. 40 913; and Timothy A. Flory, Reg. No. 42 540, my attorney(s) or agent(s) with full power of substitution and revocation, to prosecute this application and to transact all business in and to receive all correspondence from the Patent and Trademark Office connected therewith.

All statements made herein of my own knowledge are true and all statements made on information and belief are believed to be true, and further, these statements are made with the knowledge that willful false statements and the like are punishable by fine or imprisonment, or both, under 18 U.S.C. § 1001, and that such willful false statements may jeopardize the validity of this application or any patent issued thereon.

Sole or First joint inventor:

Imad Mahawili, PhD

Citizenship: USA

Residence: 3731 Oakmont, S.E.

Grand Rapids, Michigan 49546

Post Office Address: Same as above